# DESIGN AND MODELING OF ON-CHIP PLANAR CAPACITOR FOR RF APPLICATION

### MARIYATUL QIBTHIYAH BT MOHD NOOR

A project report submitted in partial fulfillment of the requirements for the award of the degree of Master of Engineering (Electrical - Electronics and Telecommunications)

Faculty of Electrical Engineering
Universiti Teknologi Malaysia

3	

To my lovely husband, Azrin Ariffin and my daughter, Lya Qistina Azrin

### **ACKNOWLEDGEMENT**

First of all, I would like to express my sincere appreciation to my project supervisor, Associate Professor Dr Mazlina Esa for encouragement, guidance, motivation and friendship.

I would also like to acknowledge my husband who gives me fully support and believe in me to do my master degree. Thank you also to my family for the neverending support since my childhood.

Lastly, I would like to thanks Associate Professor Dr Norazan Mohd Kassim and Dr Mohamad Kamal A.Rahim for giving me advices during my presentation session.

### **ABSTRACT**

On-chip radio frequency (RF) capacitor is one of the key components for RF integrated circuit (RFIC) designs such as filters and oscillators. Several researches on the design of on-chip planar capacitor have been reported. However there is a need to modify the existing synthesizing procedure; model and optimize the on-chip RF capacitor. Quality factor is the essential parameter as it is an index for the efficiency of a capacitor's performance. This thesis investigates the design of an interdigital capacitor configuration. Geometry design variables include number of fingers, finger length, finger width, finger gap, end gap, terminal width, strip thickness, substrate height, metal types and dielectric constant. The physical model of an interdigital capacitor was determined and its equivalent lumped circuit simulations have been performed. Then the optimum capacitance of the capacitor was determined. Several parameter variations on the interdigital capacitor were investigated. The effects of parameter variations on quality factor and capacitance value were discussed. An optimized interdigital capacitor can be obtained through their performance. The design has sufficient capacitance of 0.09338 pF, quality factor of 240 and operates in the 2 to 5 GHz range.

### **ABSTRAK**

Kapasitor frekuensi radio (RF) adalah satu daripada komponen utama rekabentuk litar bersepadu RF (RFIC) seperti penapis dan pengayun. Beberapa kajian berkaitan rekabentuk kapasitor sesatah atas cip telah dilaporkan. Walau bagaimanapun, terdapat keperluan untuk mengubah prosedur sintesis; permodelan dan pengoptimuman kapasitor RF atas cip. Faktor kualiti adalah parameter penting sebagai indeks kecekapan pretasi pemuat. Tesis ini mengkaji rekabentuk/konfigurasi kapasitor interdigital. Pembolehubah rekabentuk geometri meliputi bilangan jari, panjang jari, lebar jari, sela jari, hujung sela, lebar terminal, ketebalan jalur, ketebalan substratum, jenis logam dan pemalar dielektrik. Model fizikal kapasitor interdigital telah diperolehi dan simulasi litar tergumpal setara telah dilakukan. Kemudian, kapasitan optimum bagi kapasitor ini telah diperolehi. Beberapa variasi parameter terhadap kapasitor telah dikaji. Kesan variasi ini terhadap faktor kualiti dan kapasitan juga dikaji. Kapasitor interdigital yang optimum dihasilkan. Rekabentuk ini mempunyai cukup kapasitan bernilai 0.09338 pF, faktor kualiti bernilai 240 dan berkendali dalam julat 2 hingga 5 GHz.

# TABLE OF CONTENTS

CHAPTER	TITLE	PAGE
	TITLE	i
	CERTIFICATION	ii
	DEDICATION	iii
	ACKNOWLEGEMENT	iv
	ABSTRACT	v
	ABSTRAK	vi
	TABLE OF CONTENTS	vii
	LIST OF TABLES	xi
	LIST OF FIGURES	xiii
	LIST OF ABBREVIATIONS	xvi
	LIST OF SYMBOLS	xviii
	LIST OF APPENDICES	xxii
1	Introduction	1
	1.1 Objective	2
	1.2 Scope	2
	1.3 Problem Statement	3
	1.4 Project background	3

	1.5 Application of Interdigital Capacitor in RFIC	4
	1.6 Thesis Organization	7
2	Capacitor	8
	2.1 Introduction	8
	2.2 Characteristics of Capacitor	8
	2.3 Types of Capacitor	10
	2.4 On chip Interdigital Capacitor	14
3	Characterization of Interdigital Capacitor	16
	3.1 Introduction	16
	3.2 Physical Model	17
	3.3 Quality Factor	19
	3.4 Series Resistance	21
	3.5 Capacitance Calculations	22
	3.5.1 Gary D.Alley [8]	23
	3.5.2 Reza Esfandiari [9]	25
	3.5.3 Mohsen Naghed [14]	27
	3.5.4 Farsyid Aryanfar [13]	30
	3.5.5 Casares-Miranda [2]	31
	3.6 Impedances	34
	3.7 Mathematical Calculation Flow	37
4	Model Extraction and Electromagnetic Simulation	39
	4.1 Model Extraction	39
	4.2 Sub-sectioning	40
	4.3 Losses in Sonnet	44
	4.3.1 Metallzation Loss	44
	4.2.3 Dielectric Loss	47
	4.4 Q Factor	48
	4.5 Capacitance	50

	4.6 Design Methodology	50
	4.6.1 Design Flow	51
	4.6.2 ABS	52
	4.6.3 De-embedding	53
5	Analysis of Interdigital Capacitor on Silicon	56
	5.1 Introduction	56
	5.2 Mathematical Analysis	57
	5.3 Basic Design of Interdigital Capacitor	60
	5.4 Effects on Quality factor and Capacitance	64
	5.4.1 Design Comparison	64
	5.4.2 Number of Fingers	69
	5.4.3 Finger Length	72
	5.4.4 Types of Metal	75
6	Conclusions and Recommendations	78
	6.1 Conclusions	78
	6.2 Recommendations for Future Work	80
	REFERENCES	81
	APPENDIX	84
	APPENDIX A: MathCAD computation	84
	<b>APPENDIX B</b> : Example of de-embedded S-parameter results	85
	of the designed interdigital capacitor in Figure	
	5.4 (a) (0.1GHz to 9.9GHz)	
	<b>APPENDIX C</b> : Example of de-embedded Y-parameter results	89
	of the designed interdigital capacitor in Figure	
	5.4 (a) (0.1GHz to 9.9GHz)	

APPENDIX D: Example of P-Spice format results of the	93
designed interdigital capacitor in Figure 5.4(a)	
(0.1GHz to 9.9GHz)	
APPENDIX E: Results of S-Parameter of designed interdigital	99
capacitor in section 5.3.2, 5.3.3 and 5.3.4	

# LIST OF TABLES

TABLE NO.	TITLE PAGE	
2.1	Relative permittivity of insulators used in CMOS technologies	10
2.2	Summary of the properties of capacitor	12
3.1	Summarized result for Alley's calculation	24
3.2	Interdigital capacitor geometrical parameters for Mohsen's	
	experiment	29
3.3	Calculate and measured capacitances from Mohsen's experiment	29
3.4	Model parameters of an interdigital capacitor	30
3.5	Parameter value for the interdigital capacitor	32
4.1	Properties of commonly used metals	47
5.1	Suitable combination values for finger width and number	
	of fingers	58
5.2	Suitable combination values for finger spacing and number	
	of fingers	59
5.3	Suitable combination values for number of finger and finger	
	length	60
5.4	Detail design geometries of the interdigital capacitors	63
5.5	Detail design parameters of Design 1	64
5.6	$Q_{max}$ and $C$ value of different design based on Figures 5.5 to 5.7	65
5.7	$Q_{max}$ and $C$ value of different number of fingers based on	
	Figures 5.12 to 5.14	72

5.8	$Q_{max}$ and $C$ values for different finger lengths based on Figures	5.15
	and 5.16	73
5.9	$Q_{max}$ and $C$ values of different types of metal based on Figure 5	5.17
	and Figure 5.18	76

# LIST OF FIGURES

FIGURE NO.	TITLE PAGE	
1.1	An interdigital capacitor geometry	3
1.2	A mechanically tunable superconducting microwave filter	
	based on interdigital capacitor: (a) the view showing a frame	
	format of a mechanical tuning method on interdigital	
	capacitor, (b) photograph of the pre-production interdigital	
	capacitor	5
1.3	3 poles Chebyshev band pass filter of center frequency 6 GHz:	
	(a) an equivalent circuit structure, (b) layout of the lumped	
	elements band pass filter	6
2.1	Print capacitors: (a) series gap in the center conductor	
	(b) equivalent circuit of the series gap (c) interdigital	
	configuration (d) end-coupled overlay (e) end coupled	
	overlay with discrete tuning elements (f) low impedance	
	microstrip section	13
2.2	An interdigital capacitor (a) 3D view (b) equivalent circuit model	15
3.1	An interdigital capacitor (a) side view (b) top view	17
3.2	An equivalent circuit for interdigital capacitor	18
3.3	The interdigital capacitor and its subcomponents	19
3.4	Finger capacitance contributions as a function of substrate	
	thickness	24

3.5		Finger capacitance contributions as a function of substrate	
		thickness	26
3.6		Quality factors from Reza Esfandiari	27
3.7		An equivalent circuit of interdigital capacitor 27	
3.8		The circuit model of an interdigital capacitor in Farshid	
		Aryanfar's experiment	30
3.9		Circuit model of the (a) interdigital capacitor (b) wire bonded	
		interdigital capacitor	33
3.10		Simulated $C_{eff}$ of the IDC and WBIDC	34
3.11		TOP VIEW LAYOUT OF AN INTERDIGITAL CAPACITOR	
	37		
3.12		Flow chart shows mathematical calculation flow	38
4.1		Illustration of the concept of subsections which affected the	
		memory space and processing time	41
4.2		Illustration showing the default sub-sectioning values	42
4.3		Illustration of an example of subsections view for a designed	
		interdigital capacitor	43
4.4		Sonnet loss model	44
4.5		Current flow around the edge of metal	45
4.6		Flow chart shows the main process in designing interdigital	
		capacitor by using EM software	52
4.7		Circuit designs are analyzed with the DUT in order to obtain	
		analysis results	54
4.8		An example of response data generated by the designed	
		interdigital capacitor	55
5.1		Finger width versus number of finger when finger length and	
		finger spacing are fixed	58
5.2		Finger spacing versus number of finger when finger length	
		and finger width are fixed	59
5.3		Number of finger versus finger length when finger spacing	

	and finger width are fixed	60
5.4(a)	Design 1 of interdigital capacitor	61
5.4(b)	Design 2 of interdigital capacitor	61
5.4(c)	Design 3 of interdigital capacitor	62
5.4(d)	Design 4 of interdigital capacitor	62
5.4(e)	Design 5 of interdigital capacitor	63
5.5	S11 results for different designs of interdigital capacitor	66
5.6	S2results for different designs of interdigital capacitor	66
5.7	Effect on capacitance value, C for different designs	67
5.8	Effect on $Q_{max}$ for different design of interdigital capacitor	67
5.9	Enlargement of effect on $Q_{max}$ of all designs	68
5.10	Enlargement of effect on capacitance, C value for design 1	
	from 2 to 5 GHz	68
5.11	Enlargement of effect on $Q_{max}$ for design 1 from 2 to 5 GHz	69
5.12	Effect on capacitance, C value for different number of fingers	70
5.13	Effect on $Q_{max}$ for different number of fingers	71
5.14	Enlargement of effect on $Q_{max}$ for different number of fingers	71
5.15	Effect on capacitance, C value for different number of fingers	74
5.16	Effect on $Q_{max}$ for different finger lengths	74
5.17	Effect on capacitance, C value for different types of metals	77
5.18	Effect on $Q_{max}$ for different types of metals	78

### LIST OF ABBREVIATIONS

ABS : Adaptive Band Synthesis

AL : ALUMINUM

Bi-CMOS : Bipolar Complementary Metal Oxide Silicon

C : Capacitor

CAD : Computer-aided design

Cu : Copper

CMOS : Complementary Metal Oxide Silicon

dB : Decibel

DC : Direct Current

DUT : Device under test

ESR : Equivalent series resistance

EM : Electromagnetic simulation

F : Farad

FFT : Fast Fourier Transform

GaAs : Gallium Arsenide

GHz : Giga-hertz

GND ; Ground

H : Henry

HF : High frequency

Hz : Hertz

IC : Integrated circuit

IDC : Interdigital capacitor

Im : Imaginary

KHz : Kilo-hertz

L : Inductor

nH : nano Henry

Max : Maximum

MHz : Mega-hertz

MIC : Microwave integrated circuit

MIM : Metal insulator metal

Min : Minimum

MMIC : Monolithic microwave integrated circuit

MOS : Metal-oxide-semiconductor

MOSFET : Metal-oxide-semiconductor-field effect-transistor

PIP : Poly-insulator-poly

PF : pico Farad R : Resistor

Re : Real

RF : Radio frequency

RFIC : Radio frequency integrated circuit

SI : Standard International

Si : Silicon

 $SiO_2$  : Silicon oxide  $Si_3N_4$  : Silicon Nitride

S-parameter : Scattering parameter

SPICE : General purpose circuit simulation program

SRF : Self-resonant frequency

TEM : Transverse electromagnetic

Vs. : Versus

WBIDC : Wire bonded interdigital capacitor

2D : Two dimension
3D : Three dimension

### LIST OF SYMBOLS

A : Plate area

 $A_1$ : Interior capacitance of the finger

A<sub>2</sub> : Two exterior capacitance of the finger

C : Capacitance

C<sub>eff</sub> : Effective capacitance

 $C_{g}$  : Static capacitance  $C_{p}$  : Parallel capacitance

 $C_{p1}$ : The equivalent capacitances of gap discontinuous (port 1)

 $C_{p2}$ : The equivalent capacitances of gap discontinuous (port 2)

 $C_{\text{TE}}$  : Even mode capacitance

 $C_{TO}$  : Odd mode capacitance

 $C_p$  : Parallel capacitance

C1 : Parasitic capacitance

C2 : Parasitic capacitance

d : Separation between the plates

E : Electric field

f : Frequency

G : Conductance

g<sub>e</sub> : Finger end gap

h : Substrate height

I : Electric current

L : Inductance

1 : Finger length

 $\begin{array}{cccc} l_T & : & Length \ of \ terminal \ strip \\ L_{TE} & : & Even \ mode \ inductance \\ L_{TO} & : & Odd \ mode \ inductance \\ n & : & Number \ of \ fingers \end{array}$ 

P# : Port number

Q : Quality factor

Qc : Quality factor due to conductor losses
Qd : Quality factor due to dielectric losses

Q<sub>max</sub> : Maximum quality factor

q<sub>1total</sub> : Total charge on the inner conductor (port 1) q<sub>2total</sub> : Total charge on the inner conductor (port 2)

 $q_1$ : Charge per unit length on the connected transmission

lines (port1)

 $q_{2}$ : Charge per unit length on the connected transmission

lines (port2)

R : Resistance

 $R_{DC}$  : DC resistance

 $R_{RF}$ : Skin effect coefficient

R<sub>s</sub> : Series resistance

 $R_T$ : Resistance of the conductors

s : Finger spacing

 $S_{11}$ : Input reflection coefficients

 $S_{12}$  : Reverse transmission coefficients  $S_{21}$  : Forward transmission coefficients

S<sub>22</sub> : Output reflection coefficients

 $\begin{array}{cccc} t & : & Strip \ thickness \\ V_{in} & : & Input \ voltage \end{array}$ 

V<sub>o</sub> : Peak voltage across the circuit terminal

 $V_{out}$  : Output voltage  $w_t$  : Terminal width

x : Finger width

Y<sub>11</sub> : Admittance seen looking into port 1 when port 2 is short-circuit

Y<sub>12</sub> : Transfer admittance when port 1 is short-circuit
Y<sub>21</sub> : Transfer admittance when port 2 is short-circuit

Y<sub>22</sub> : Admittance seen looking into port 2 when port 1 is short-circuit

Z<sub>in</sub> : Input impedance

Z<sub>c</sub> : Characteristic impedance for series configuration
 Z<sub>s</sub> : Characteristic impedance for shunt configuration

 $Z_{oo}$  Even mode impedance  $Z_{oe}$  Odd mode impedance  $Z_{T}$  : Characteristic impedance

 $Z_{11}$ : Impedance at 1 when port 2 is open

Z<sub>12</sub> : Transition impedance when port 1 is short-circuit
 Z<sub>21</sub> : Transition impedance when port 2 is short-circuit

 $Z_{22}$ : Impedance at 2 when port 1 is open

 $\alpha_{\chi}$  : Attenuation constant for series configuration  $\alpha_{\sigma}$  : Attenuation constant for shunt configuration

) : Metal resistivity at DC

 $\delta$  : Metal skin depth

 $\mu$  : Permeability

 $\mu_0$  : Free space permeability

 $\mu_r$  : Relative magnetic permeability

 $\varepsilon$  : Real part of dielectric permittivity

 $\varepsilon_c$  : Relative dielectric constant for series configuration

 $\varepsilon_r$ : Relative dielectric constant

 $\varepsilon_o$  : Free space dielectric constant

 $\varepsilon_s$  : Relative dielectric constant for shunt configuration

 $\gamma_{TE}$ : Even mode propagation constant

 $\gamma_{TO}$  : Odd mode propagation constant

μm : Micron meter

 $\eta_o$  : Free space impedance

 $\Omega$  : Unit of resistivity, ohm

 $\omega$  :  $\omega$  radian frequency, rad/s

φ : Magnetic flux

 $\sigma$  : Bulk conductivity

 $\pi$  : 22/7

 $\lambda \hspace{1.5cm} : \hspace{1.5cm} Unit \ of \ wavelength$ 

# LIST OF APPRENDICES

APPRENDIX NO.	TITLE	PAGE
Appendix A	MathCAD Computation	84
Appendix B	Example of de-embedded S-parameter results of	85
	the designed interdigital capacitor in Figure 5.4 (a)	
	(0.1GHz to 9.9GHz)	
Appendix C	Example of de-embedded Y-parameter results of	89
	the designed interdigital capacitor in Figure 5.4 (a)	
	(0.1GHz to 9.9GHz)	
Appendix D	Example of P-Spice format results of the designed	93
	interdigital capacitor in Figure 5.4(a) (0.1GHz to	
	9.9GHz)	
Appendix E	Results of S-Parameter of designed interdigital	99
	capacitor in section 5.3.2, 5.3.3 and 5.3.4	

### Chapter 1

### Introduction

Advances in Complementary Metal Oxide Silicon (CMOS) fabrications have resulted in deep submicron transistors with higher transit frequencies and lower noise figure [17]. This advanced performance of Metal-Oxide-Semiconductor-Field-Effect-Transistor (MOSFET) is attractive for high-frequency (HF) circuit design in view of a system on-chip realization, where digital, mixed-signal base-band and HF transceiver blocks would be integrated on a single chip. Besides the ability to integrate RF circuit with other analog and logic circuit with the intention of reducing the cost by eliminating the sometimes-expensive packaging, other advantages offered by silicon CMOS technologies are low cost due to the volume of wafers processed and the low power consumption, which makes it suitable for portable applications.

Many research activities are studying the possibilities to migrate the RF circuit to CMOS technology. The on-chip planar capacitor is one of the major areas of such investigation.

27

### 1.1 Objective

The objective of this research is to model and design an optimized RF interdigital capacitor for Radio Frequency Integrated Circuit (RFIC) application.

### 1.2 Scope

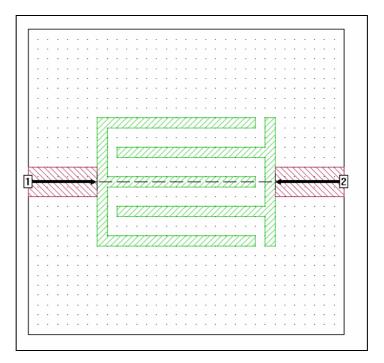
The scopes of the research are as follows:

- Determination of the physical model of an interdigital capacitor and its equivalent lumped circuit
- Usage of MathCAD software for mathematical configuration
- Determine the optimum capacitance of the capacitor
- Simulation of the physical layout of the capacitor using SONNET simulation software
- Analyzing the performance of the designed interdigital capacitor
- Thesis writing

The design specification is as follows:

Quality factor Q : 240 to 250
Capacitance C : 0.08 to 0.2 pF
Operating frequency f : 2 to 5 GHz

Figure 1.1 shows as example of the design geometry.



**Figure 1.1** An interdigital capacitor geometry

### 1.3 Problem Statement

In CMOS applications, RFICs are developing a strong presence in the commercial world. The advantages of RF CMOS technology are low cost, low power consumption, small in size, high integration, high reliability and high volume production. However, it has been found that the greatest obstacle for achieving high quality RF system with CMOS technology comes from the passive components. The reliability and the efficiency of CMOS RF system can be improved by realizing on-chip RF passive component, such as on-chip capacitor. Hence, there is need to design and model an optimized on-chip capacitor fabricated on Silicon substrates.

### 1.4 Project Background

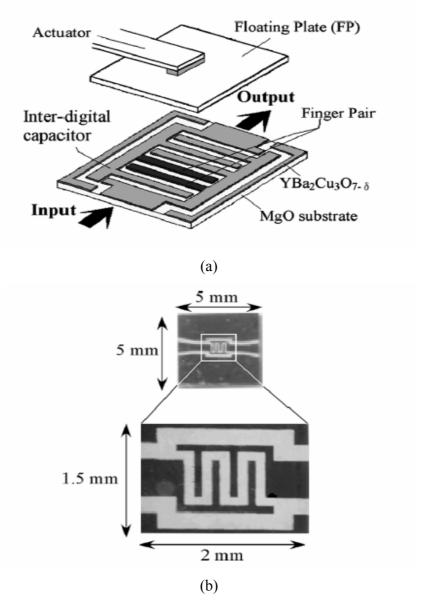
This project investigates the design of an interdigital capacitor. Geometry design variables include number of fingers (n), finger length (l), finger width (x), finger gap (s), end gap  $(g_e)$ , terminal width  $(w_l)$ , strip thickness (t), substrate height (h), metal types and dielectric constant. The optimum design of an interdigital capacitor can be identified through contour plot of the quality factor (Q-factor). This project involves mathematical computation using MathCad and electromagnetic simulation using SonnetLite Plus. This optimum design of an interdigital capacitor can be used for RF applications such as filter and oscillator. Microstrip interdigital capacitors (IDCs) have been widely used as a quasi-lumped element in high frequency and high-speed integrated circuits (ICs). [8]

Capacitors have become ubiquitous in analog-integrated circuits particularly owing to the switched capacitor technique for realization of analog-to-digital and digital-to-analog data converters and discrete time filters.

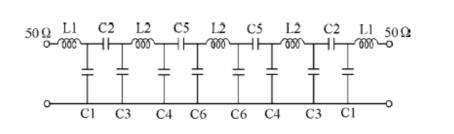
### 1.5 Application of Interdigital Capacitor in RFIC

Capacitors are one of the most crucial elements in mixed-signal integrated circuits. These are used extensively in many RFIC applications such as RF oscillator, filter, mixer, data converters, sample and holds and switched capacitor circuits.

Figure 1.2 and Figure 1.3 shows a mechanically tunable superconducting microwave filter based on interdigital capacitor an interdigital capacitor bandpass filter, respectively.



**Figure 1.2** A mechanically tunable superconducting microwave filter based on interdigital capacitor: (a) the view showing a frame format of a mechanical tuning method on interdigital capacitor, (b) photograph of the pre-production interdigital capacitor [11].



interdigital capacitor

C3

C4

C4

C1

C3

T5.0

T9.96 mm

(b)

**Figure 1.3** 3 poles Chebyshev band pass filter of center frequency 6 GHz: (a) an equivalent circuit structure, (b) layout of the lumped elements band pass filter [11].

### 1.6 Thesis Organization

Chapter 1 presents the introduction of this project report which includes objective, scope, project background and application of interdigital capacitor in RFIC. Chapter 2 presents the literature review on the characterization of capacitor, types of capacitor and on-chip interdigital capacitor. Chapter 3 is mainly focused on the physical modeling of an interdigital capacitor. It includes the derivation of the equations of capacitance and equation of *Q* factor. The calculation flow using MathCad software is also been discussed in this chapter. Chapter 4 presents the design procedures of using the electromagnetic simulator and some design loss issues such as metallization and dielectric losses. Chapter 5 is mainly focused on the analysis of results and discussion. The results are presented into two parts. The first part is the mathematical computations using MathCad software while the second part is the electromagnetic simulation result using SonnetLite Plus. The effect on *Q* factor and capacitance over different designs, varying number of fingers, types of metals and finger lengths are presented and discussed. Chapter 6 concludes the thesis. Also presented in this chapter are recommendations for future work.

### REFERENCES

- T.Ytterdal, Y.Cheng, T.A. Fjeldly, Device Modeling for Analog and RF CMOS Circuit Design. Wiley 2003
- 2. F.P.Casares-Miranda, P.Otero, E.Marquez-Segura, C.Camacho-Penalosa "Wire Bonded Interdigital Capacitor," IEEE Trans Microwave and Wireless Components, Vol. 15, No. 10, 2005
- 3. S.Hontsu,S.Mine,H.Nishikawa,M.Nakamori,A.Fujimaki,M.Inoue,A.Maehara, T.Kawai, "Study of Mechanically Tunable Superconducting Microwave Filter Using Lumped Elements," IEEE Trans.on Applied Superconductivity Vol3,No.2,2003
- 4. Leo G.Maloratsky, Passive RF & Microwave Integrated Circuits. Elsevier 2004
- 5. R.Brown"RF/Microwave Hybrids:Basics,Materials and Processes," Kluwer Academic Publishers 2002
- 6. W.F.Mullin, ABC's of Capacitors, Howard W.Sams & Co 1966
- 7. Ian Sinclair, Passive Components for Circuit Design, Newnes 2001
- 8. Gary.D.Alley,"Interdigital Capacitor and Their Application to Lumped-Element
  Microwave Integrated Circuits",IEEE Trans. Microwave Theory Tech,Vol
  MTT-18 1970
- 9. R.Esfandiari, D.W.Maki, M.Siracusa, "Design of Interdigital Capacitor and Their Application to GaAs Filters", IEEE Trans. Microwave Theory Tech, Vol MTT-31 1983
- J.L.Hobdell, "Optimization of Interdigital Capacitors," IEEE Trans. Microwave Theory Tech, Vol MTT-27 1979

- 11. E.Pattenhaul, H.Kapusta, A.Wisgerber, H.Mempe, J.Luginsland, I.Wolff, "CAD Models of Lumped Elements on GaAs up to 18GHz", IEEE Trans. Microwave Theory Tech, Vol MTT-36 1988
- 12. M.Naghed, I.Wolff,"Equivalent Capacitances of Coplanar Waveguide Discontinuities and Interdigital Capacitors Using a Three Dimensional Finite Difference Method," IEEE Trans. Microwave Theory Tech, Vol 38 No.12,1990
- F.Aryanfar, K.Sarabandi "Characterization of Semilumped CPW Elements for Millimeter-Wave Filter Design," IEEE Trans. Microwave Theory Tech Vol 53, No. 4,2005
- 14. Inder Bahl, Prakash Bhartia, Microwave Solid State Circuit Design. Wiley 2003
- 15. A.Naderi, M.Sawan, Y.Savaria, "A 1mW 2GHz Q Enhanced LC Bandpass Filter for Low Power RF Applications," IEEE Trans. Microwave Theory Tech, 2005
- 16. L.Zhu,K.Wu," Accurate Circuit Model of Interdigital Capacitor and Its Application to Design of New Quasi Lumped Miniturized Filters with Suppression of Harmonic Resonance," IEEE Trans. Microwave Theory Tech,Vol 48, No3,2000
- 17. J.Zhou,M.J.Lancaster,F.Huang,"Superconducting Microstrip Filters Using

  Compact Resonators with Double-Spiral Inductors and Interdigital

  Capacitors," IEEE Trans. Microwave Theory Tech,2003
- 18. L.Zhu,K.Wu, "A General Purpose Circuit Model of Interdigital Capacitor for Accurate Design of Low Loss Microstrip Circuit," IEEE Trans. Microwave Theory Tech, 1998
- S.S.Gevorgian, T.Martinsson, Peter L, J. Linner, E.L. Kollberg, "CAD Models for Multilayered Substrate Interdigital Capacitors," IEEE Trans. Microwave Theory Tech, Vol 44 No.6,1998
- K.Chang, Inder Bahl, Vijay Nair, RF and Microwave Circuit and Component Design for Wireless Systems. Wiley 2002
- 21. Queennie S.I.Lim, Albert V.Kordesch, Richard A.Keating, "Performance Comparison of MIM Capacitors and Metal Finger Capacitors for Analog and RF Application," 2004 RF and Microwave Conference, 2004

- 22. R.S.Chen,X.Zhang,K.F.Tsang,K.N.Yung,"Modeling and Design of Interdigital Capacitor Based on Neural Networks and Genetic Algorithm," Microwave and Optical Technology Letters Vol.38,No.3,2003
- 23. I.Kneppo, J.Fabian, Microwave Integrated Circuits, Chapman & Hall 1994